

<b>Notice of References Cited</b>	Application/Control No. 10/602,508	Applicant(s)/Patent Under Reexamination SMEE ET AL.	
	Examiner Jean B. Corrielus	Art Unit 2611	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0146129 A1	07-2004	Lin, Chan-Shih	375/348
*	B	US-6,603,801 B1	08-2003	Andren et al.	375/147
*	C	US-2003/0152176 A1	08-2003	Ghosh, Monisha	375/350
*	D	US-7,027,538 B2	04-2006	Ghosh, Monisha	375/350
*	E	US-2004/0131109 A1	07-2004	Kim et al.	375/148
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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